



ELECTRONIC COPY

LG632460996
Report verification at igi.org



June 21, 2024
IGI Report Number **LG632460996**
Description **LABORATORY GROWN DIAMOND**
Shape and Cutting Style **CUT CORNERED
RECTANGULAR MODIFIED
BRILLIANT**
Measurements **8.51 X 5.69 X 3.70 MM**
GRADING RESULTS
Carat Weight **1.56 CARAT**
Color Grade **D**
Clarity Grade **VVS 1**
Cut Grade **EXCELLENT**

LABORATORY GROWN DIAMOND REPORT

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IGI Report Number **LG632460996**
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Measurements **8.51 X 5.69 X 3.70 MM**

GRADING RESULTS

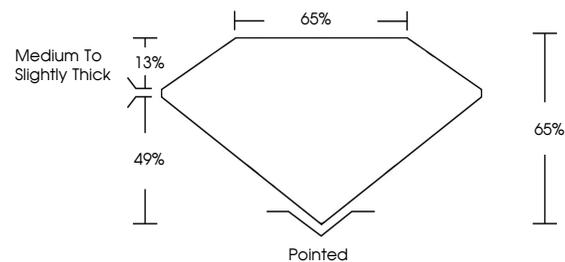
Carat Weight **1.56 CARAT**
Color Grade **D**
Clarity Grade **VVS 1**
Cut Grade **EXCELLENT**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG632460996**

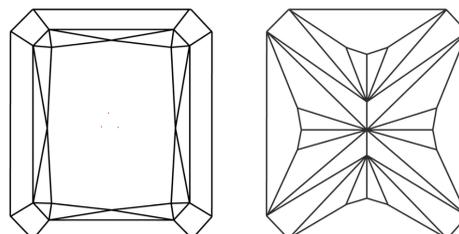
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

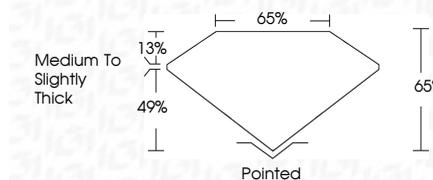
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

IF	VS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
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CUT CORNERED RECT. MODIFIED BRILLIANT
8.51 X 5.69 X 3.70 MM
Carat Weight **1.56 CARAT**
Color Grade **D**
Clarity Grade **VVS 1**
Cut Grade **EXCELLENT**
Depth **65%**
Table **65%**
Girdle **Medium To Slightly Thick**
Culet **Pointed**
Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscriptions(s) **IGI LG632460996**
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa